



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

In Re PATENT APPLICATION Of:

Applicant: Mikio OHTAKI

Appln. No.: 09/904,663

Filed: July 16, 2001

For: METHOD FOR MANUFACTURING  
AND BATCH TESTING  
SEMICONDUCTOR DEVICES

Atty Ref.: KAN 120D1

AMENDMENT

September 4, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
**Mail Stop – Non-Final Office Action**

Sir:

Responsive to the Examiner's Action dated May 7, 2003, a Petition for a One-Month Extension of Time being submitted herewith, please amend the application as shown on the following pages.

**FEE ENCLOSED: \$100,<sup>00</sup>**  
**Please charge any further**  
**fe to our Deposit Account**  
**No. 18-0002**